

Notice of References Cited	Application/Control No. 10/827,202	Applicant(s)/Patent Under Reexamination ADETUTU ET AL.	
	Examiner Caridad M. Everhart	Art Unit 2891	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-2004/0198009	10-2004	Chen et al.	438/303
	B	US-2005/0045923	03-2005	Chambers, James J.	257/288
	C	US-2004/0213971	10-2004	Colburn et al.	428/209
	D	US-2004/0121614	06-2004	Baek et al.	438/743
	E	US-6,228,723	05-2001	Kim, Yong-Tae	438/283
	F	US-5,959,337	09-1999	Gardner et al.	257/410
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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	N					
	O					
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	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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